

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : 10/566,116 Confirmation No. 3700
Applicant : Akihisa Inoue et al.
371 Filed : January 24, 2006
Art Unit : 1734
Examiner : Weiping Zhu
Customer No. : 00270
Title : SPUTTERING TARGET AND METHOD FOR PRODUCTION
THEREOF

Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Sir:

This is an Amendment timely submitted with a Request for Continued Examination (RCE) in response to a FINAL Office Action dated August 4, 2011. Kindly amend the application as set forth below.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 7 of this paper.